

## Implantation of Radioactive 119Sb

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journal or	CYRIC annual report
publication title	
volume	1980
page range	125-127
year	1980
URL	http://hdl.handle.net/10097/48587

## V. 23 Implantation of Radioactive 119 Sb

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Implantation of radioisotopes combined with internal-conversion spectroscopy is giving a unique method in solid-state physics and in chemistry in that the contact density of valence electron can be separated from the core contributions.  $^{1,2}$ ) Such a project is in progress and up to now implantation of  $^{119}$ Sb ( $^{11}$ <sub>2</sub> = 38 h) has been conducted; the decay of this nucleus leads to the Mössbauer transition of 23.8 keV in  $^{119}$ Sn.

A natural Sn metal target was irradiated for several hours by an  $\alpha$  beam from the cyclotron at  $\rm E_{\alpha}$  = 45 MeV and  $\rm I_{\alpha}$  ~ 15  $\rm \mu A$  . The target was welded onto a copper plate in vacuum; the copper plate was cooled during bombardment. After cooling short-lived activities for 1 day the target surface corresponding to the thickness of  $\alpha$ -particle penetration (~0.5 mm) was scraped off using a "target scraper" as shown in Fig. 1. From the sample of irradiated Sn ( $\sim$  1 g)  $^{119}$ m Te  $(T_{1/2} = 4.6 \text{ d})$  produced mainly by  $^{118}\text{Sn}(\alpha, 3n)^{119m}$ Te was chemically separated as explaned in Fig. 2. After waiting 4 days for the daughter nuclide 119 Sb to grow from  $^{119\text{m}}\text{Te}$ ,  $^{119}\text{Sb}$  was separated from the Te fraction (milking); see Fig. 2. From the Sb fraction, 119 Sb together with stable Sb carrier was electroplated onto a Pt foil of 20  $\mu\text{m}$  thickness or a Pt wire of 25  $\mu\text{m}$  diameter, and the latter was put into the oven of a Nielsen-type ion source of the electromagnetic isotope separator of this center. The 119Sb was separated and implanted at 60 kV in the collector chamber of the separator onto a Sn foil. The total implantation efficiency of 119 Sb was measured using a pure-germanium low-energy photon spectrometer; the maximum efficiency was 0.5 % but it was not stable and changed from time to time. The efficiency was found to depend strongly on the mass-separated current for A = 119, the main part of which is probably due to  $^{119}$ Sn from the target. A typical implantation process monitored by the 121Sb+ current is shown in Fig. 3. The intensity of implanted  $^{119}$ Sb was ~10  $\mu$ Ci.

The Mössbauer spectrum of the implanted sample was measured for the 23.8 keV gamma rays in \$^{119}\$Sn at a liquid-nitrogen temperature. After a thermal annealing of the implanted sample for 40 sec at 150°C in an Ar atmosphere, a Mössbauer absorption dip was obtained against a standard absorber of CaSnO3, indicating a substitutional site of the implanted \$^{119}\$Sb in Sn metal. The study of Mössbauer measurement is still in progress in order to define a good condition of annealing.

In view of the possible mixing in implantation from stable  $^{119}$ Sn of the target, we are also trying to produce  $^{119}$ Sb by the Sb(p, 3n) $^{119m}$ Te reaction in which the stable isotopes of Sb have A = 121 and 123 and such a possibility of mixing can be excluded.

## References

- 1) Spijkervet W. J. J. and Pleiter F., Hyperfine Interactions 7 (1979) 285.
- 2) Spijkervet W. J. J., Pleiter F. and de Waard H., to be published (Calibration of the Isomer Shift of <sup>83</sup>Kr).
- 3) De Waard H., private communication (Sept., 1980).

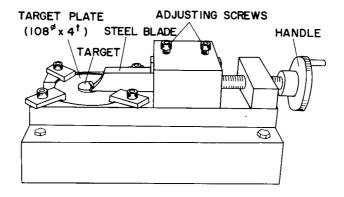


Fig. 1. Target Scraper. The top of the target is scraped off before irradiation, and a spacer of appropriate thickness is placed below the target plate to define the thickness of scraping after irradiation.

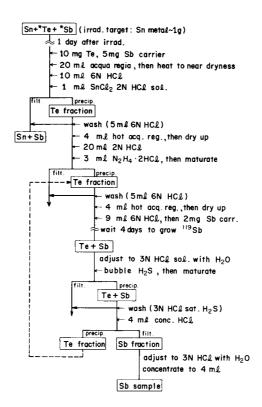


Fig. 2. Block diagram of chemical separation of  $^{119\,\mathrm{m}}\mathrm{Te}$  from the Sn target and that of  $^{119}\mathrm{Sb}$  from the Te fraction.

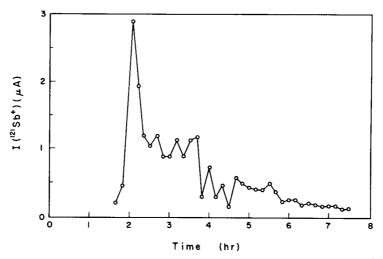


Fig. 3. Monitoring of the implantation with the current of stable  $^{121}\text{Sb}^+$ . In this example the total implantation efficiency of  $^{121}\text{Sb}$  was 0.9 % whereas that of  $^{119}\text{Sb}$  was 0.3 %.